



Attorney's Docket No.: 8034 USA/W-C/W-C/HMM
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Christopher Laurent Beaudry, et al.

Application No: 10/736,007

Filing Date: December 15, 2003

For: SINGLE WAFER CLEANING
METHOD TO REDUCE PARTICLE
DEFECTS ON A WAFER SURFACE

Examiner: Duy V.N. Deo

Art Unit: 1765

I hereby certify that this correspondence is being deposited with the
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Commissioner for Patents
P.O. Box 1450
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PETITION FOR EXTENSION OF TIME
PURSUANT TO 37 C.F.R. § 1.136 (a)

Sir:

Applicant respectfully petitions pursuant to 37 CFR 1.136(a) for a one-month extension of time to file this response to the Office Action mailed April 6, 2006. The extended period is set to expire on August 6, 2006. Please use charge deposit account 02-2666 to cover the fee for a one-month extension of time.

Pursuant to 37 C.F.R. 1.136(a)(3), applicant(s) hereby request and authorize the U.S. Patent and Trademark Office to (1) treat any concurrent or future reply that requires a petition for extension of time as incorporating a petition for extension of time for the appropriate length of time and (2) charge all required fees, including extension of time fees and fees under 37 C.F.R. 1.16 and 1.17, to Deposit Account No. 02-2666.

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Please charge any shortages and credit any overages to our Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR AND ZAFMAN LLP

Dated: July 31, 2006


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